# Electronic Version v1.1 Stylesheet Version v1.1

SUBMISSION TYPE: **NEW ASSIGNMENT** NATURE OF CONVEYANCE: SECURITY AGREEMENT

### **CONVEYING PARTY DATA**

Name	Execution Date
Negevtech Ltd.	03/30/2008

### RECEIVING PARTY DATA

Name:	Plenus II, L.P.
Street Address:	16 Abba Eben Avenues
City:	Herzeliya Pituach
State/Country:	ISRAEL
Postal Code:	46726

Name:	Plenus II (D.C.M)
Street Address:	16 Abba Eben Avenues
City:	Herzeliya Pituach
State/Country:	ISRAEL
Postal Code:	46726

### PROPERTY NUMBERS Total: 28

Property Type	Number
Patent Number:	6693664
Patent Number:	7180586
Patent Number:	6892013
Patent Number:	7260298
Patent Number:	7274444
Application Number:	10345097
Application Number:	11476342
Application Number:	11476356
Application Number:	11476358
Application Number:	11476322
	DATENT

PATENT

500570834 **REEL: 021118 FRAME: 0061** 

Application Number:	11524684
Application Number:	11709019
Application Number:	60587675
Application Number:	11895204
Application Number:	11069712
Application Number:	11068711
Application Number:	11410276
Application Number:	60808816
Application Number:	11684191
Application Number:	11503859
Application Number:	11590650
Application Number:	60861303
Application Number:	11944677
Application Number:	11700408
Application Number:	11781454
Application Number:	11764296
Application Number:	11944684
Application Number:	61027586

### **CORRESPONDENCE DATA**

Fax Number: (617)526-5000

Correspondence will be sent via US Mail when the fax attempt is unsuccessful.

Phone: 617-526-6448

Email: janey.davidson@wilmerhale.com

Correspondent Name: Michael J. Bevilacqua, Esquire

Address Line 1: Wilmer Cutler Pickering Hale and DorrLLP

Address Line 2: 60 State Street

Address Line 4: Boston, MASSACHUSETTS 02109

ATTORNEY DOCKET NUMBER:	110373146
NAME OF SUBMITTER:	Michael J. Bevilacqua

### **Total Attachments: 7**

source=negevtech security agreement plenus#page1.tif source=negevtech security agreement plenus#page2.tif source=negevtech security agreement plenus#page3.tif source=negevtech security agreement plenus#page4.tif source=negevtech security agreement plenus#page5.tif source=negevtech security agreement plenus#page6.tif source=negevtech security agreement plenus#page7.tif

# U.S. INTELLECTUAL PROPERTY SECURITY AGREEMENT

This U.S. INTELLECTUAL PROPERTY SECURITY AGREEMENT ("IP Security Agreement") dated March 30, 2008, is made by (i) NEGEVTECH Ltd. (the "Grantor"), a company organized under the laws of the State of Israel, with offices located at 12 Hamada St. Rehovot 76703 Israel, and (ii) Plenus II, L.P, an Israeli limited partnership registered number 55021817-6 and Plenus II (D.C.M), an Israeli limited partnership number 55-021825-9 (collectively, "Plenus"), whose registered office is at 16 Abba Eben Avenues, Herzeliya Pituach 46726, Israel.

WHEREAS, Plenus and the Grantor entered into that certain Loan Agreement (the "Loan Agreement") dated October 11, 2005, to which a Debenture - Floating Charge (the "Debenture - Floating Charge") and a Debenture Fixed Charge (IP) (the "Debenture - Fixed Charge (IP)") in each case executed by the Grantor and Plenus, are attached as exhibits.

WHEREAS, under the terms of the Loan Agreement, Grantor has agreed, among other things, to grant a first raking floating charge over the intellectual property of Grantor to Plenus and the Grantor has agreed as a condition thereof and in addition to the creation of the charges pursuant to the Debenture - Fixed Charge (IP), and the Debenture - Floating Charge, to execute this IP Security Agreement for recording with the U.S. Patent and Trademark Office and other governmental authorities on any intellectual property owned by it throughout the term of this IP Security Agreement.

**NOW, THEREFORE**, for good and valuable consideration, the receipt and sufficiency of which are hereby acknowledged, and intending to be legally bound hereby, Grantor agrees as follows:

Section 1. Grant of Security. Subject to the provisions of the Debenture - Floating Charge and the Debenture - Fixed Charge (IP) (collectively, the "Charge Agreements"), Grantor hereby grants to Plenus a first ranking security interest in and to all right, title and interest to (i) the registered United States patents and pending applications, including but not limited to the patents and patent applications set forth in Schedule A hereto together with all reissues, divisions, continuations, continuations-in-part, extensions and reexaminations thereof, and all rights therein provided by international treaties or conventions (the "Patents"), (ii) the trademarks, service marks, trade names and domain names, including but not limited to the registrations and applications therefor set forth in Schedule A hereto together with all goodwill associated with such trademarks and service marks and all rights therein provided by international treaties or conventions (the "Trademarks"), and (iii) all copyrights and registrations and applications therefor set forth in Schedule A (the "Copyrights") currently owned by the Grantor or which shall be owned in the future by the Grantor (the "Collateral"). Schedule A shall be deemed to be automatically updated, and the Grantor shall promptly file amendments to Schedule A with the U.S. Patent and Trademark Office, upon the application for or acquisition of any new Patents or Trademarks in the United States and with the United States Copyright Office upon the application for or acquisition of any new registrations for Copyrights.

Section 2. <u>First Ranking</u>. The security granted to Plenus hereunder shall rank in priority to any other security interests created by Grantor over the Collateral.

. <u>Section 3. Security for Obligations</u>. The grant of a security interest in the Collateral by Grantor under this IP Security Agreement secures the payment of all money and liabilities owed or incurred by Grantor now or hereafter existing under or in respect of the Loan Agreement and related agreements (the "Secured Obligations").

Section 4. <u>Recordation</u>. Grantor authorizes and requests that the Commissioner of Patents and Trademarks and any other applicable government officer record this IP Security Agreement.

Section 5. <u>Power of Attorney</u>. In the event that Plenus is permitted to receive the Collateral under the Charge Agreements, Grantor hereby grants to Plenus power of attorney to inspect, take all necessary or desired action, and prosecute any Patents, Trademarks, Copyrights or applications for any of the foregoing that may be included in the Collateral.

Section 6. <u>Right to Request Information</u>. Plenus shall have the right to request, and Grantor shall promptly provide upon such request, information reasonably required in order to confirm that Schedule A is updated.

Section 7. Grants, Rights and Remedies. This IP Security Agreement has been entered into in conjunction with the provisions of the Loan Agreement and the Charge Agreements. The Grantor does hereby acknowledge and confirm that the grant of the security interest hereunder to, and the rights and remedies of, Plenus with respect to the Collateral are more fully set forth in the Loan Agreement and/or the Charge Agreements and in the event of any contradiction between this IP Security Agreement and the Loan Agreement or the Charge Agreements will prevail.

Section 8. Governing Law; Forum for Dispute Resolution. This Agreement shall be governed by and construed according to the laws of the State of Israel, without regard to the conflict of laws provisions thereof. Any dispute arising under or in relation to this Agreement shall be resolved in the competent court for the Tel Aviv-Jaffa district, and each of the parties hereby submits exclusively and irrevocably to the jurisdiction of such court.

Section 9. <u>Termination</u>. This IP Security Agreement and the security interest granted hereunder to Plenus shall terminate and be of no force upon satisfaction in full of the Secured Obligations. Upon termination, Plenus shall execute all documents necessary to remove the security interest granted thereto by Grantor hereunder.

[REMAINDER OF PAGE LEFT INTENTIONALLY BLANK]

IN WITNESS WHEREOF, Grantor and Plenus have caused this IP Security Agreement to be duly executed and delivered by its officer thereunto duly authorized as of the date first above written.

### **NEGEVTECH LTD.**

By: R. Shor new
Name: Rivi Sherman
Title: CEO
PLENUS II, L.P
Ву:
Name:

PLENUS II (D.C.M)

By:

Name:

Title:

# SCHEDULE A PATENTS



# Appendix A

Dov Furman, Ehud Tirosh, Shai Silberstein	NRI-15-P	D&M	Filed		2/11/2008	2/11/2008	Inspection Tools Supporting Multiple Operating 2/11/2008	61/027,586	US-Prov 1	17   US-	10-807/100
Dov Furman, Roi Kaner, Ori Gonen, Daniel Mandelik, Eran Tal, Shai Silherstein	NRI-13	D&M	Pending	1	11/26/2007		Image splitting in Optical Inspection Systems		S 1	<b>├</b> -	$\vdash$
Gilad Shomroni, Arnon Gratch, Shai Silberstein	NRI-9	D&M	Pending	'	6/18/2007	6/18/2007	Optical Inspection Including Partial Scanning Of Wafers	11/764,296	US -	.t.	0015-US-01
Giora Eitan, Shai Silberstein		D&M	Pending		7/23/2007	7/23/2007	Optical Inspection Tool Featuring Multiple Speed Modes	11/781,454	US 1	J.	0014-US-01
Erez Sali, Oren Cohenm, Zeev Litichever	NRI-5	D&M	Pending		1/31/2007	1/31/2007	Advanced Cell-To-Cell Inspection	11/700,408	US 1	13	10-80-6100
Dov Furman, Shai Silberstein, Effy Miklatzky, Daniel Mandelik Martyn Ayraham	NRI-7	D&M	Pending		11/26/2007	11/06;11/07	Image splitting in Optical Inspection Systems		.US 2	<u>.                                    </u>	<del> </del>
Dov Furman, Shai Silbertein	NRI-7-P	D&M	Filed	·	11/28/2006	11/28/2006	Image splitting in Optical Inspection Systems	60/861,303	US-Prov I	12 US	0012-03-01
Erez Sali, Oren Cohen	NRI4-CON H	D&M	Pending	'	12/18/2007	10/31/2006	Defect Detection through Image Comparison Using Relative Measures		US 2	-	┢
Erez Sali, Oren Cohen	NRI-4	D&M	Allowed	ı	10/31/2006	10/31/2006	Defect Detection through Image Comparison Using Relative Measures	11/590,650	.US 1	T	0011-US-01
Dov Furman, Daniel Mandelik	NRI-3	D&M	Pending		8/14/2006	8/14/2006	Speckle Reduction Using a Fiber Bundle and Light Guide	11/503,859	.US 1	10	0010-US-01
Dov Furman, Shai Silbertein	NRI-2	D&M	Pending	,	3/9/2007	5/26/2006	Wafer Inspection Using Short-Pulsed Continuous Broadband Illumination	11/684,191	.US 2	9	0009-US-02
Dov Furman, Shai Silbertein		D&M	Filed	•	5/26/2006	5/26/2006	Water Inspection Using Short-Pulsed Continuous Broadband Illumination	60/808,816	US-Prov 1	9 US	10-SU-6000
Dan Fuchs, Shai Silberstein	NRI-I	D&M	Pending	,	4/24/2006	4/24/2006	Printed Fourier Filtering In Optical Inspection	11/410,276	1	0	0000-00-01
Yuval Dorfan, Ran Zaslavsky, Mark Wagner, Dov Furman, Shai Silberstein	53604	STC	Pending	,	2/28/2005	2/28/2005	Method and apparatus for detecting defects in wafers including alignment of the wafer images so as to induce the same smear in all images	11/068,711	US	-	0007-US-01
Erez Sali, Tomer Yanir, Mark Wagner, Noam Dotan, Yuval Dorfan, Ran Zaslavsky	53603	STC	Pending	1	2/28/2005	2/28/2005	Method and apparatus for detecting defects in wafer	11/069,712	.US 1	6	0006-US-01
Dov Furman, Noam Dotan, Efraim Miklatzky		STC	Pending	-	8/22/2007	7/12/2004	Multimode inspection method and apparatus	11/895,204	US 3	4	0004-US-03
Dov Furman, Noam Dotan, Etraim Miklatzky	53885	STC	Issued		7/6/2005	7/12/2004	Multimode inspection method and apparatus	7274444	US 2	4	0004-US-02
Dov Furman	004/3	SIC	Filed		7/12/2004	7/12/2004	Multimode inspection method and apparatus	60/587,675	2		0004-US-01
Dov Furman		SIC	Issued	7.002/17/9	3/31/2003	1/15/2003	Fiber ordinal illumination system	11/709.019	4	4	0003-US-03
Doy Furman, Gad Neumann, Noam Dotan		STC	Issued	5/10/2005	1/15/2003	1/15/2003	Fiber optical illumination system	7 260 298	115 2	ω (	0003-US-02
Gad Neumann & Noam Dotan	53751	STC	Issued	2/20/2007	12/23/2004	1/15/2003	System for detection of wafer defects	7,180,586	US 7	+	0002-US-07
Dov Furman, Gad Neumann, Noam Dotan, Ram Segal. Shai Silberstein	55247	STC	Pending		9/21/2006	1/15/2003	System for detection of wafer defects	11/524,684	.US 6		0002-US-06
Dov Furman, Gad Neumann, Noam Dotan, Ram Segal, Shai Silberstein	55070	STC	Pending		6/28/2006	1/15/2003	System for detection of wafer defects	11/476,322	.US 5	12	0002-US-05
Dov Furman, Gad Neumann, Noam Dotan, Ram Segal, Shai Silberstein	55147	STC	Pending		6/28/2006	1/15/2003	System for detection of wafer defects	11/476,358	US 4		0002-US-04
Dov Furman, Gad Neumann, Noam Dotan, Ram Segal, Shai Silberstein	55072	STC	Closed		6/28/2006	1/15/2003	System for detection of wafer defects	11/476,356	.US 3	2	0002-US-03
Dov Furman, Gad Neumann, Noam Dotan, Ram Segal, Shai Silberstein	55071	STC	Pending		6/28/2006	1/15/2003	System for detection of wafer defects	11/476,342	US 2	2	0002-US-02
Dov Furman, Gad Neumann, Noam Dotan, Ram Segal, Shai Silberstein	44420	STC	Pending	•	1/15/2003	1/15/2003	System for detection of wafer defects	10/345,097	.US I	2	0002-US-01
Gad Neumann	44623	STC	Issued		6/18/2002	6/30/1999	Method and system for fast on-line electro- optical detection of wafer defects	6,693,664	.US 1	-	10-SU-1000
Inventors	Attorney file name Inventors	Attorney	Status	Issue date	Prior date Filing date	Prior date	Title	Official No.	untry #	amily Co	NT file name Family Country

Allowed - Application was allowed by the examiner but a didn't issued yet Closed - Application was closed after filing Filed - A PCT or a provisional application was filed In summarizing - Negevtech is preparing the invention summary to the patent attorney In writing - The patent attorney works on the application text

Issued - patent was issued. Patent number is assigned Pending - Application was filed and yet didn't allowed

# **Trademarks**

Registration #	Registration Date	Owned By	<u>Mark</u>

# **List of Trademark Applications:**

Serial #	Filing Date	Owned By	<u>Mark</u>	
77332770	November 19, 2007	Negevtech Ltd.	NEGEVTECH	

### **Domain Names:**

Negevtech.com

Negevtech.co.il

Negevtech.us

Negevtech.net

Negevtech.info

Negevtech.biz

Negevtech.co.uk

Negevtech.de

Negevtech.cn

Negevtech.com.cn

Negevtech.tw

Negevtech.com.tw

# Copyrights

Registration #	Registration Date	Owned By	Title

# ANNEX I

**Inter-Creditor Agreement** 

US IP Security Agreement FNL Plenus doc

RECORDED: 06/19/2008